

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	Confirmation No.: 5877
Kenichi MORIMOTO	Art Unit: 1763
S. N. 10/737,393	Examiner: Allan W. Olsen
Filed: December 16, 2003	

For: MASK BLANK FOR CHARGED PARTICLE BEAM EXPOSURE, METHOD OF
FORMING MASK BLANK AND MASK FOR CHARGED PARTICLE BEAM EXPOSURE

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT AND RESPONSE TO
OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the notice of non-compliant amendment, for which a petition to revive is submitted herewith, and in response to office action to the office action dated July 16, 2007, please make the following amendments:

Claim amendments begin on page 2 of this document.

Remarks begin on page 4 of this document.